

**CERTIFICATE OF ELECTRONIC
TRANSMISSION**

I hereby certify that this correspondence for Application No. 10/524,525 is being electronically transmitted to Technology Center 1765, via EFS-WEB, on December 26, 2007.

/David H. Brinkman/ 12/26/07
David H. Brinkman, Reg. No. 40,532 Date

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Martin Hausner
Serial No.: 10/524,525
Filed: August 18, 2005
Confirmation No.: 1134
Group Art Unit: 1765
Examiner: Ahmed, Shamim
Title: **METHOD FOR SELECTIVELY REMOVING MATERIAL FROM
THE SURFACE OF A SUBSTRATE, MASKING MATERIAL FOR
A WAFER, AND WAFER WITH MASKING MATERIAL**
Atty. Docket: BEET-09

*OK to
enter
SA
1/14/08*

Cincinnati, Ohio 45202

December 26, 2007

Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

AFTER FINAL RESPONSE

In response to the Final Office Action mailed on September 26, 2007,
please amend the above-identified application as follows:

Amendments to the Claims are reflected in the listing of claims which
begins on page 2 of this paper.

Remarks/Arguments begin on page 11 of this paper.